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CONFIRMATION NO. 1482

<b>SERIAL NUMBER</b> 10/529,861	<b>FILING OR 371(c) DATE</b> 03/31/2005 <b>RULE</b>	<b>CLASS</b> 205	<b>GROUP ART UNIT</b> 1742	<b>ATTORNEY DOCKET NO.</b> HOK-0270
<b>APPLICANTS</b> Tetsuji Shibata, Hirakata-shi, JAPAN; Keiichi Yamazaki, Gose-shi, JAPAN; Noriyuki Taguchi, Otsu-shi, JAPAN; Yasushi Sawada, Neyagawa, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/07598 05/26/2004 <i>are 10-19-07</i>				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-149961 05/27/2003 <i>are 10-19-07</i> JAPAN 2003-330351 09/22/2003 <i>are 10-19-07</i>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>A. Michael</i> <i>are</i> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 14	<b>TOTAL CLAIMS</b> 28
				<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> 23353				
<b>TITLE</b> Plasma processing apparatus, method for producing reaction vessel for plasma generation, and plasma processing method				
<b>FILING FEE RECEIVED</b> 1300	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	